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Hybrid Spintronic Structures With Magnetic Oxides and Heusler Alloys


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Hybrid spintronic structures, integrating half-metallic magnetic oxides and Heusler alloys with their predicted high spin polarization, are important for the development of second-generation spintronics with high-efficient spin injection. We have synthesized epitaxial magnetic oxide Fe3O4 on GaAs(100) and the unit cell of the Fe3O4 was found to be rotated by 45° to match the gallium arsenide GaAs. The films were found to have a bulk-like moment down to 3–4 nm and a low coercivity indicating a high-quality magnetic interface. The magnetization hysteresis loops of the ultrathin films are controlled by uniaxial magnetic anisotropy. The dynamic response of the sample shows a heavily damped precessional response to the applied field pulses. In the Heusler alloy system of Co2MnGa on GaAs, we found that the magnetic moment was reduced for thicknesses down to 10 nm, which may account for the lower than expected spin-injection efficiency from the spin-light-emitting diode structures. Using the element-specific technique of X-ray magnetic circular dichroism (XMCD), the reduced spin moments were found to originate from the Mn rather than the Co atoms, and the improvement of the interface is thus needed to increase the spin injection efficiency in this system. Further studies of the T–V characteristics of Fe3O4/GaAs(100) and Fe2O3/MgO/GaAs(100) show that the Fe3O4-based spintronic structures have a well-defined Schottky or tunneling barrier of moderate barrier height, which is encouraging for high-efficient spin injection.

Index Terms—Gallium arsenide (GaAs), Heusler alloys, magnetic oxides, magnetite, molecular-beam epitaxy, spintronics, ultra-thin films.

I. INTRODUCTION

The discovery of giant magnetoresistance in the metallic multilayers in the early 1980s initiated and propelled spintronics research, resulting in the first generation of a spintronic device in the form of the spin valve for recording heads. This was followed by the discovery of tunneling magnetoresistance, leading to the magnetic tunnel junction (MTJ) that has been utilized in developing magnetic random-access memory (MRAM). The second-generation spintronics, integrating magnetic materials with semiconductor devices, will not only improve the existing capabilities of electronic devices, but will add new functionalities, enabling future computers to run faster, while consuming less energy, which is expected to have an impact comparable to the development of the transistor 50 years ago. However, magnetic materials and semiconductors have been developed in parallel quite separately over the decades with magnetic materials mainly used for data storage, such as computer hard disks and semiconductor devices for data processing, such as the field-effect transistor (FET) and metal–oxide semiconductor field-effect transistor (MOSFET) in the IT industry. It is thus a major challenge to integrate magnetic materials with semiconductors for the second-generation spintronics [1]. There are currently two classes of material systems exploited: 1) dilute magnetic semiconductors (DMS), such as Ga1−xMnxAs and Cd1−xCoxSe, and 2) magnetic/semiconductor hybrid spintronic structures (HySpin), such as Fe/GaAs, Co/Si, Fe3O4/GaAs, Co2MnGa/GaAs. DMSs have the great advantage of integrating with conventional semiconductor materials and devices [2]–[4]. However, it remains a real challenge to increase their Curie temperature. The highest $T_c$ obtained so far in III–V and II–VI DMSs is $\sim 150$ K. To overcome the low solubility of magnetic impurities, such as Mn in semiconductor compounds, DMSs have been grown at a low temperature to avoid secondary-phase formation. Postgrowth annealing has also been adopted to further improve the sample structures and increase the Curie temperature. Some new DMSs have been discovered in the last few years that might—or might not—exhibit ferromagnetic behavior above room temperature, such as Co-doped TiO2 (Co2Ti1−xO2). On the other hand, hybrid spintronic structures (HySpin) have the advantages of high Curie temperatures, well-controlled magnetic properties, and easy integration with current magnetic technologies. Recently, an encouraging approach to achieve high-efficient spin injection into semiconductors in the diffusive regime has been the use of a spin-dependent energy barrier, such as MgO, which is a good insulating material with high thermal stability. Spin-injection efficiency as high as 55% at 100 K has already been demonstrated by Parkin et al. [5] in a CoFe/MgO/GaAs tunneling structure. The ferromagnetic metal/semiconductor hybrid structures [6]–[8] are so far the most extensively
studied hybrid spintronic materials. The growth of epitaxial ferromagnetic metal/semiconductor hybrid structures was first demonstrated in Fe/GaAs by Prinz’s group at the Naval Research Laboratory. This is possible, in part, due to the fact that the lattice constant of bcc Fe is approximately half that of GaAs. To achieve high spin injection into semiconductors, the development of high-spin-polarized magnetic materials and their integration with the semiconductor are essential. Half-metallic Fe$_2$O$_4$ has attracted great attention recently as it has high polarization at the Fermi level and relatively high electrical conductivity at room temperature, which is believed to benefit the injection of spin carriers into the semiconductors. The epitaxial growth of Fe$_2$O$_4$ on MgO [9]–[11] Al$_2$O$_3$ and Pt [12] has been demonstrated by several groups and several interesting magnetic properties, such as superparamagnetism, slow saturation behavior, and local out-of-plane magnetic moments in zero field, have been observed. In order to incorporate Fe$_2$O$_4$ into spintronics devices, the synthesis of Fe$_2$O$_4$ on semiconductor substrates, such as GaAs, is essential. Heusler alloys are considered to be promising materials for spin injectors because they belong to the material class of magnetic half metals. Half metals are magnetic materials with a band gap at the Fermi level for one spin direction and continuous bands for the opposite spin direction. Due to this band asymmetry, the minority electrons are semiconducting and the majority electrons persist their normal metallic characteristics, which consequently gives rise to a situation where the conduction electrons at the Fermi level are 100% spin polarized [13]. Heusler alloys also possess the properties of having matching lattice constants with III-V semiconductors and high Curie temperatures ranging from 200 to 1200 K.

In this paper, we report our studies of growth, structure analysis, and magnetic properties of hybrid spintronic materials and devices, in particular, with the magnetic oxides and Heusler alloys. All samples were grown by the molecular beam epitaxy (MBE) technique. We focus on two systems: Fe$_2$O$_4$ and Co$_2$MnGa, on GaAs-based spintronic structures. The full Heusler alloy Co$_2$MnGa is one of the most promising Heusler alloys for the integration with the semiconductor since its lattice matches very well with III-V semiconductor, such as GaAs. We have previously shown that epitaxial Fe$_2$O$_4$ could be grown on GaAs despite their relatively large lattice mismatch [14]. Our study emphasizes the growth, structures, and interface and magnetic properties since they are critically important to understand and control the spin injection in hybrid spintronics devices.

II. EPITAXIAL GROWTH AND STRUCTURES

A. Fe$_2$O$_4$/GaAs and Fe$_2$O$_4$/MgO/GaAs

There are essentially two different approaches to synthesize Fe oxides from atomic Fe. The first one is the growth of Fe in an oxygen environment at a suitable substrate temperature. The second one is first to grow Fe on the substrate and then to use an oxidant agent to oxidize the Fe to iron oxide. In the first approach, the incident Fe atoms in the vapor beam are oxidized before reaching the surface and being deposited. This method generates a homogeneous chemical composition throughout the film. However, there are some problems related to this method. First, the oxidation of the substrate surface (e.g., the GaAs(100) surface) is problematic. In the oxidant agent environment, which should be constructed prior to the Fe oxide growth, the GaAs(100) itself might be oxidized before Fe oxide deposition. This incurs a GaAs(100) oxide interface between the bulk GaAs and the Fe oxide. Second, there is a possible chemical stoichiometric variation depending on the oxidant agent and substrate temperature, etc. Third, the growth of Fe oxide on the Fe oxide might induce antiphase boundaries (APBs) in the films. The second approach is postgrowth oxidation, where Fe is epitaxially grown on the GaAs(100) prior to oxidation. This approach leads to an ultrathin Fe oxide film of high quality owing to the oxidation mechanism applied here. It is known that in the oxidation process of thick Fe film, the electrons migrate from the inner atomic Fe/oxygen interface to the oxide/oxygen surface and combine with oxygen to form O$_2^-$ anions. The Fe oxides, going from Fe to oxygen rich, range from FeO, Fe$_2$O$_3$ to Fe$_3$O$_4$. Due to the intrinsic nature of the oxide, the thickness ratio of each oxide depends on the potential energy. If the Fe film is ultrathin, such as a few nanometers, then the composition dependence on depth might disappear and uniform stoichiometry might be achieved.

We have developed this second approach to grow the Fe$_2$O$_4$ films on GaAs. Ultrathin single crystal Fe films were first grown on the GaAs substrate by MBE, and the sample was exposed to O$_2$ in the growth chamber, maintaining the O$_2$ partial pressure at $5 \times 10^{-5}$ mbar using a leak valve. Fig. 1(a) and (b) shows the RHEED patterns of the GaAs(100) substrates and a 3-nm-thick Fe$_2$O$_4$ film after 3 min. of oxidation at a substrate temperature of 500 K. Similar to the discussion of Fe on the GaAs(100) substrate, the oxide exhibits a fourfold symmetry in the film plane, which gives rise to similar RHEED patterns with the electron beams along the [011] and [0–11] directions. The sharper RHEED pattern in Fig. 1(b) confirms a more uniform Fe$_2$O$_4$ growth here in comparison with our previous studies [14], which may be due to the well-ordered GaAs surface obtained after in-situ annealing as shown by the clear Kochiki lines. The RHEED patterns also suggested a rotation of 45° in the growth relationship, namely Fe$_2$O$_4$ (100)$<011>/GaAs(100)<010>$ with the unit cell of Fe$_2$O$_4$ rotated by 45° to match that of the GaAs(100) substrate. With a 3-nm MgO interlayer grown at a GaAs substrate temperature of 673 K, an epitaxial relationship, MgO(100)$<001>/GaAs(100)<001>$ was obtained, as shown by the RHEED pattern of the MgO included in Fig. 1(c), despite the large lattice mismatch (25.5%) of MgO and GaAs. Further growth of 3–nm film of Fe$_2$O$_4$ on top of the MgO/GaAs structure using the same conditions as described before gives rise to the overall growth relationship of Fe$_2$O$_4$ (100)$<001>/MgO(100)<001>$./GaAs(100)$<001>$, which can be seen in Fig. 1(d). Notice that the Fe$_2$O$_4$ unit cell rotates 45° back compared to the case of Fe$_2$O$_4$/GaAs because the rotation gives a nearly perfect lattice match between Fe$_2$O$_4$ and MgO. Using XPS measurements, we have further confirmed that the samples are Fe$_2$O$_4$ rather than $\gamma$-Fe$_2$O$_3$, which has a similar crystal structure as Fe$_2$O$_4$. The magnetic coupling of the samples was characterized using X-ray magnetic circular dichroism (XMCD), which is capable of probing the magnetic
signal from sites of different chemical environments. The ferromagnetic magnetite features an inverse spinel structure in which the tetrahedral sites are entirely occupied by Fe\textsuperscript{3+} cations but the octahedral sites are equally filled by Fe\textsuperscript{3+} and Fe\textsuperscript{4+} cations, which has been confirmed by our XMCD measurements of the ultrathin Fe\textsubscript{3}O\textsubscript{4} films.

B. Heusler Alloys Co\textsubscript{2} MnGa on GaAs and Spin-LED

Thin films of the ferromagnetic Heusler alloy Co\textsubscript{2} MnGa were grown epitaxially using MBE on GaAs(100) substrates that were overgrown with 1 \( \mu \)m of GaAs and capped with a few \( \mu \)m of amorphous As. Prior to the growth of the Heusler thin films, the surface of the substrates was cleaned in-situ by As desorption in an ultra-high vacuum up to a temperature of \( \sim 450^\circ C \). Two effusion cells and an e-gun source provided atomic beams of Mn, Ga, and Co. Deposition rates were monitored using quartz-crystal microbalances and a quadrupole mass spectrometer. The growth temperature used was 250 \( ^\circ C \), which has been chosen for two reasons. First, at lower temperatures, the thin film could have many structural defects, such as dislocations and antisites, and second, but at higher temperatures, where the crystal has only few defects, the diffusion at the interface between substrate and film will form a magnetic dead layer, which could cause spin scattering and quenching of the spin polarization, leading to an unusable material for spintronics device applications. The used growth temperature is thought to be the highest temperature without any confirmed interface diffusion layer and it is similar to that reported to grow some other Heusler alloys (200 \(^\circ C\)–300 \(^\circ C\)), such as NiMnSb [15], [16], Ni\textsubscript{2} MnGa [17], Co\textsubscript{2} MnGe [18] and Co\textsubscript{2} MnSi [19], [20]. Using a mechanical shutter very close to sample during growth, the Co\textsubscript{2} MnGa thin films were fabricated as a staircase comprised of different thicknesses. The Co\textsubscript{2} MnGa layers were finally capped with a 2.0 nm layer of either Al or Au. By observing in-situ reflection high-energy electron diffraction (RHEED) patterns during growth, an initial determination of crystal quality was obtained. Fig. 2 shows RHEED patterns taken after the MBE growth of the Co\textsubscript{2} MnGa film on GaAs p-i-n spin-LED structure.

A high-resolution X-ray diffraction (XRD) technique for \( \theta \)-2\( \theta \) scans and \( \omega \) -scans was used to investigate the detailed crystal structure of the Heusler alloys on GaAs. Fig. 3 illustrates the epitaxial growth of a 9.7-nm Co\textsubscript{2} MnGa film on GaAs(100).

We found that the film evolves from a strained film with inplane lattice parameters matched with GaAs \( a = 5.65 \) Å into a relaxed film with bulk lattice constant \( a = 5.77 \) Å at a critical thickness of \( \sim 10 \) nm.

III. MAGNETIC MOMENTS OF ULTRATHIN Fe\textsubscript{3}O\textsubscript{4} FILMS

Fe\textsubscript{3}O\textsubscript{4} has a spinel structure, where the unit cell contains two Fe\textsuperscript{3+} ions equally occupying the tetragonal A site and octahedral B sites and one Fe\textsuperscript{2+} ion in the B site. The local magnetic moments on the B sites are antiparallel to that on the A site. Thus, the net magnetic moment is contributed solely by the Fe\textsuperscript{2+} ion, which has an atomic value of \( \sim 4 \mu_B \), disregarding the contribution of the orbital moment. The total magnetization was measured with vibrating sample magnetometer (VSM) at room temperature. Based on the measured thickness and the area of the Fe films before oxidation, we calculated the number of Fe atoms in each film. Then, dividing the measured magnetic moment of the Fe\textsubscript{3}O\textsubscript{4} film by three of the calculated total number of Fe atoms, we obtain the average numbers of Bohr magneton per formula unit (f.u) in the Fe\textsubscript{3}O\textsubscript{4} film.

Fig. 4 shows the thickness dependence of the magnetic moment per formula unit of the magnetite films with the nominal thicknesses varying from 2 to 8 nm. A comparison with the theoretical value of \( \sim 4 \mu_B \) for the magnetic moment of Fe\textsubscript{3}O\textsubscript{4} shows that for the thinnest film of 2 nm, the moment is less than the theoretical value, which may be understood as being due to an incomplete film structure, such as in epitaxial superparamagnetic-clustered Fe [18], [21]. For the 8-nm film, the magnetic
moment per formula unit is much higher than \(4 \mu_B\) which might be possibly due to some residual Fe not being fully oxidized under the Fe\(_2\)O\(_4\) layer. The magnetization of the 4- and 6-nm films are nearly but slightly less than \(4 \mu_B\), which suggests that these films are fully oxidized to half metallic Fe\(_2\)O\(_4\) and have almost stoichiometric composition. We also like to point out that the magnetic moment of the Fe\(_2\)O\(_4\) films might contain a contribution from the orbital magnetic moment, which requires further study.

IV. INTERFACE MAGNETIZATION AND SPIN-INJECTION EFFICIENCY WITH Co\(_2\)MnGa

Most of the reported magnetization measurements of Heusler alloys have been on bulk materials or thick films. We have recently studied the ultrathin Heusler films of less than 10 nm with XMCD and VSM measurements in order to obtain some insight in the interface magnetic properties, which is critical to spin-injection in various spin devices such as spin-LED. Mn and Co \(L_{2,3}\) X-ray absorption (XA) and XMCD spectra were recorded at room temperature using 70% circularly polarized soft x-rays from beamline 1.1 at the Synchrotron Radiation Source (SRS) in Daresbury Laboratory, UK. Magnetic fields up to 0.6 T were applied parallel and antiparallel to the photon helicity vector using the Portable Octupole Magnet System (POMS). XA spectra were collected using the total-electron yield (TEY) detection method with the sample surface inclined at an angle of 30° to the X-ray beam. Fixed photon helicity was used to obtain the XMCD signal at each point of the spectrum by reversing the direction of the applied magnetic field along the X-ray beam. A typical set of XMCD spectra for both the Mn L\(_{2,3}\) and Co L\(_{2,3}\) edges from 9.7 nm Co\(_2\)MnGa/GaAs(100) samples is shown in Fig. 5. The spectra were analysed quantitatively by applying the sum rules to assess the element-specific magnetic moments [21], [22] and the results are summarised in Table I. The difference between the magnetic moment values from the VSM and XMCD measurements could be associated with the physical limitations on probing depth using the XMCD technique since soft X-rays are expected to penetrate only to depths of up to 5 nm [23]. Both the XMCD and VSM measurements suggest that the magnetic moments are greatly reduced in the ultrathin films and, thus, at the interface. The Co sites still have a moment close to the theoretical values, but a large transfer of the magnetic moment from the Co to the Mn sites appears to be absent despite the average Co moment being reduced from its bulk value of \(\sim 1.7 \mu_B/\)atom [24]. The reason behind these discrepancies is not yet fully clear. Though the tiny shoulders of the Co L\(_2\) and L\(_3\) edges might indicate a very slight oxidization of the Co, it is, however, unlikely to cause the reduced moments at the Mn site. Calculations carried out by the group from DTU and KU have suggested that Mn defects residing on Co sites may antialign themselves with the applied field [25]. Based on depth profiling Auger data [24], we have found that Mn tends to diffuse toward the surface into Al. The large change of the magnetic moment upon increasing the thickness from 5.3 to 7.6 nm suggests that there might be an interface layer with a much lower magnetic moment than the rest of the film. Its origin appears to be due to the diffusion of substrate atoms into the alloy films, which is known to significantly change the local magnetic moments [26], [27].

We have carried out optical measurements in the oblique Hanle effect geometry to measure the electrical spin injection into an InGaAs quantum well in the i-region of a GaAs p-i-n LED device with Heusler alloy spin injectors. The first Co\(_2\)MnGa Heusler alloy spin LED [29] was fabricated on a highly doped Al\(_{0.3}\)Ga\(_{0.7}\). As Schottky barrier that had already been optimized for spin injection with Fe. Hanle geometry electroluminescence measurements determined that the spin injection from the nonstoichiometric alloy Co\(_{2.4}\)Mn\(_{1.6}\)Ga was 13% efficient at 5 K, which meant the optical polarization efficiency in the spin LED was only 2.4%. An interfacial disorder limited this value and in addition, the polarization signal disappeared.
above 20 K. The same spin LED with an Fe contact could operate at 300 K with 1% efficiency and at 5 K with 31% efficiency. At low temperatures, a dynamic nuclear polarization signal could be observed with the Heusler alloy contact, which meant that subtle spin interaction effects could still be observed in the semiconductor device even with relatively inefficient spin injection. A Co$_2$MnGe Heusler alloy spin LED [30] had an efficiency of 27%, which represents the limiting value with an epitaxial Heusler alloy even when the band structure is predicted to be half metallic. In more recent stoichiometric Co$_2$MnGa structures [31], the spin-injection efficiency is 22%. This lower than expected spin-injection efficiency is correlated with the reduced interface magnetization as observed from the XMCD and VSM measurements.

V. STATIC AND DYNAMIC SWITCHING

As a bulk ferromagnetic ferrite, magnetite shows a cubic magnetic anisotropy, with the easy, medium, and hard axes along the <111>, <110>, and <100> directions, respectively, above 130 K. Using MOKE measurements, we have studied the magnetization hysteresis loops along four major directions. We found that the films show strong uniaxial magnetic anisotropy in a thickness range of 2–8 nm, as illustrated in Fig. 6 by the MOKE loops from a 3-nm film. The easy axis of the uniaxial anisotropy is along the [0–11] orientation of the GaAs(100) substrate. The films have a relatively low coercivity of only 12 Oe as expected from epitaxial growth. The saturation field along the hard axis is 80 Oe, which is proportional to the uniaxial magnetic anisotropy fields. The influence of cubic anisotropy ($K_1$) becomes stronger compared to that of the uniaxial ($K_u$) with increasing thickness. As a consequence of the increase in the ratio of $K_1/K_u$, the global easy axis rotates from the uniaxial easy [0–11] direction to the cubic easy [001] direction, when the thickness is above 6 nm. The uniaxial magnetic anisotropy might be related to the interface as that observed in the Fe/GaAs system. There are generally two mechanisms associated with “unidirectional chemical bonding” and “magnetoelastic coupling,” respectively, that explain the uniaxial magnetic anisotropy in the magnetic/semiconductor hybrid structures. These two mechanisms might be responsible for the uniaxial magnetic anisotropy observed here. However, the interface of Fe$_3$O$_4$/GaAs(100) is even more complicated than that of Fe/GaAs(100) as first the ultrathin Fe$_3$O$_4$ itself might be different from the bulk, and second, the bonding of oxygen to the semiconductor surface is not clear so far.

**Dynamic switching** has also been measured in the single-crystal Fe$_3$O$_4$ using MOKE techniques. The picosecond magnetization dynamics induced by a pulsed magnetic field have a precessional character that is sensitive to the temporal profile and orientation of the pulsed field and the magnetic properties of materials, such as magnetic anisotropies and magnetic damping that are present. Dynamic magnetization switching measurements provide essential information for the application of this material system into spintronic devices, such as understanding the ultimate limit of the switching speed [32], [33]. A field-pumped time-resolved magneto-optical Kerr effect (TRMOKE) setup has been used to investigate time-resolved magnetization dynamics of epitaxial Fe$_3$O$_4$ ultra-thin films [34]. The field pulse used to trigger the dynamics has a 10–90% rise time of 350 ps, a decay time of ~1 ns, and a peak field of 1 kOe. The magnetization dynamics of the sample are probed using the polar MOKE effect, giving a measurement of the out-of-plane component of magnetization. The dynamic response of the sample to the field pulse was measured for different dc bias fields applied along two perpendicular crystalline directions. Fig. 7 shows the measured dynamic response of the 3-nm sample to the field pulse at a dc bias field of 720 Oe. By fitting the Landau–Lifshitz–Gilbert (LLG) equation, we found that the damping constant of the Fe$_3$O$_4$ ultrathin films is ~0.1, significantly exceeding that of its metallic Fe counterpart of ~0.01. This might be related to the ferromagnetic coupling in Fe$_3$O$_4$ as well as the interface bonding and magnetoelastic coupling as indicated by the static hysteresis measurements. The heavy damping suggests a potentially higher working frequency of spintronic devices made of this half metallic material.

**VI. INTERFACE SCHOTTKY BARRIER AND TUNNELING BARRIER**

Apart from the fundamental magnetic properties, the nature of the interface contact and the barrier height is also one of the key issues for the hybrid spintronic devices. We have carried out $I$–$V$ measurements across the Fe$_3$O$_4$ and n-doped GaAs interface and the results are shown in Fig. 8(a). The nonlinear behavior in the low-bias region can be attributed to the Schottky

| Thickness (nm) | Mn$_{total}$ (µm) | Co$_{total}$ (µm) | XMCD (m$_{total}+2m_{23}$) | VSM |  |
|---------------|-------------------|-----------------|---------------------------|-----| |
| 5.3           | 0.534             | 0.175           | 0.19                      | 0.15 | |
| 7.6           | 0.724             | 0.305           | 0.46                      | 0.61 | |
| 9.7           | 0.470             | 0.341           | 0.23                      | 0.70 | |
| Bulk [28]     | 3.01              | 0.52            |                           |     | |
barrier near the interface. The forward and reverse current resulted in an asymmetric bias voltage. This diode-like behavior is typical for Schottky barriers. There are three different mechanisms responsible for the Schottky effect: 1) diffusion of the carrier from the semiconductor to the magnetite thin film; 2) thermionic emission of the carrier across the Schottky barrier; or 3) quantum mechanical tunnelling through the barrier. We found that the thermionic emission-diffusion model best fits the experimental results. Assuming an effective Richardson constant [35] of 8.2 A cm$^{-2}$ K$^{-2}$, the Schottky barrier height was found to be 0.34 eV. This is about half of the Schottky barrier height of the metal/GaAs contact, such as Fe/GaAs, which lies within the range 0.69–0.72 eV. It is interesting to note that the Schottky barrier height of the MBE-grown magnetite is less than the 0.58–0.63 eV Schottky barrier height observed by Watts et al. [36] in the magnetite thin films deposited on top of the GaAs(100) by reactive dc sputtering. This indicates that the Schottky barrier height of the Fe$_3$O$_4$/GaAs contact depends on the growth condition, which may be controlled to have the desired barrier heights for spin injection.

We have further characterized the Fe$_3$O$_4$-based structures with the MgO interface and the result is included in Fig. 8(b). It is interesting to observe that the $I$–$V$ curve is much less asymmetric than that without the MgO barrier. The result suggests that electrical current in the Fe$_3$O$_4$ (4 nm)/MgO/GaAs(100) structure is determined by the tunneling process between the magnetite and GaAs through the MgO barrier. We have fitted the $I$–$V$ curve with the Simmons model [37] which is capable of determining the barrier width and height of the tunnelling structure. We found that the barrier width and height obtained from the best fit of the Simmons model are 3 nm and 0.8 eV, respectively, for the Fe$_3$O$_4$/MgO/n-GaAs junctions. Detailed simulations will be published elsewhere. The fitted barrier height is comparable to the values reported for MTJs with MgO barriers deposited by various techniques [38], [39], whereas the barrier width is in good agreement with the calibrated thickness of the MgO. The full epitaxial Fe$_3$O$_4$/MgO/GaAs(100) structure combining the half metallic Fe$_3$O$_4$ and high-quality MgO barrier forms a promising platform of high-efficient spin injection for spintronic applications.

VII. CONCLUSION

We have reported the growth, structure, interface, and magnetic properties of magnetic/semiconductor hybrid spintronic structures based on half-metallic oxides and Heusler alloys. By using postgrowth annealing, we have synthesized the epitaxial magnetic oxide Fe$_3$O$_4$ on GaAs(100) and the unit cell of the Fe$_3$O$_4$ was found to rotate by 45° to match GaAs. The films were found to have a bulk-like moment down to 3–4 nm, indicating a magnetic interface suitable for high-efficient spin injection. The ultrathin films have a low coercivity of around 120e, and the magnetization is controlled by a uniaxial anisotropy related to the strain or chemical bonding at the interface. The dynamic measurements show that the films have heavy damping and, thus, can be switched fast. A moderate Schottky barrier of around 0.3 eV was found at the Fe$_3$O$_4$/GaAs interface, which is favorable for spin injection. In the Heusler alloy systems, such as Co$_2$MnGa on GaAs, we found the magnetic moment was reduced by more than 50% for the thickness down to 10 nm. Using the element-specific XMCD technique, we further found that the reduced spin moments arise from the Mn rather than the Co. Although the growth and magnetic properties of Heusler alloys have been explored for the last ten years, this study suggests that more work is required to improve the growth of Heusler alloy/semiconductor hybrid spintronics structures to have a clean interface in order to make use of this encouraging material system. It is still not clear why spin polarization is much lower than the expected 100% and the predicted large magnetic moment transfer from the magnetic elements, such as Co, to other elements, such as Mn, is not observed in the ultrathin films of a few nanometers thick. Considering the large spin polarization, high Curie temperatures, fast switching, and the moderate barriers with either a Schottky contact or MgO layer, the half-
metallic oxide/semiconductor hybrid structures might be one of the most promising second-generation spintronics systems. We would also like to point out that while the hybrid spintronic structures integrating half-metallic magnetic oxides and Heusler alloys are exciting for second-generation spintronics, a major challenge remains, however, to improve the Heusler alloy/semiconductor interface and to integrate the magnetic oxides with semiconductor devices to fulfill the promised great potential of these half metallic materials with a predicted spin polarization of 100%.

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